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From-PILLSBURY WINTHROP SHAW PITTMAN #4

+6502234747

T-138 P.001/002 F-337

Docket Number: 061450-0304608

Client Reference: FID-101 D4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of: Prakash

Application No.: 10/613,439  
Filed: July 3, 2003

Examiner: Davis, R. Raevis  
Group Art Unit: 2856  
Confirmation No.: 5116

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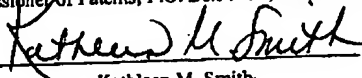
JUN 30 2005

For: **ATOMIC FORCE MICROSCOPY MEASURES OF CONTACT RESISTANCE AND  
CURRENT-DEPENDENT STICTION**

Date of Deposit: June 30, 2005

I hereby certify that this paper and attachments identified below are being transmitted via facimile (703-872-9306) addressed to the  
Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date indicated above.

By:

  
Kathleen M. Smith

INFORMATION DISCLOSURE STATEMENT

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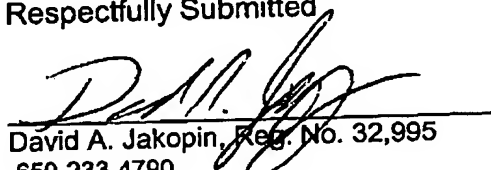
Sir:

The art identified in the accompanying IDS form 1449, which was cited in related applications, is being placed with this file solely to obviate any subsequent suggestion of inequitable conduct. All references cited therein are US patents and thus, copies are not provided. Applicant does not consider this art as being relevant; at best, it is merely cumulative with other previously cited references.

The subject patent will issue July 5, 2005 as U.S. Patent 6,912,894. Applicant is not requesting further examination, but only that this submission be placed in the file history.

Dated: June 30, 2005

Respectfully Submitted

  
David A. Jakopin, Reg. No. 32,995  
650-233-4790

PILLSBURY WINTHROP SHAW PITTMAN LLP  
2475 Hanover Street  
Palo Alto, CA 94304-1114  
Customer Number: 27498

